

Notice of References Cited	Application/Control No. 10/572,907		Applicant(s)/Patent Under Reexamination NAKAZAWA, NAOFUMI	
	Examiner Timothy J. Henn		Art Unit 2622	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0135672	09-2002	Sezan et al.	348/36
*	B	US-6,834,128	12-2004	Altunbasak et al.	382/284
*	C	US-6,307,550	10-2001	Chen et al.	345/418
*	D	US-2005/0008254	01-2005	Ouchi et al.	382/284
*	E	US-2005/0104902	05-2005	Zhang et al.	345/629
*	F	US-6,392,658	05-2002	Oura, Koutatsu	345/629
*	G	US-7,424,218	09-2008	Baudisch et al.	396/322
*	H	US-6,941,029	09-2005	Hatori, Kenji	382/284
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.